



Docket No.: 8733.713.10-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Han-Wook Hwang

Application No.: 10/733,237

Confirmation No.: 9469

Filed: December 12, 2003

Art Unit: 2822

For: POLY-CRYSTALLINE THIN FILM  
TRANSISTOR AND FABRICATION  
METHOD THEREOF

Examiner: Not Yet Assigned

**REQUEST FOR CORRECTED FILING RECEIPT**

Filing Receipt Corrections  
Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby requests that a corrected Filing Receipt be issued in the above-identified patent application. The official Filing Receipt received by Applicant, a copy of which is attached hereto, has an error in the

Applicant's information-**Residence has been omitted;**

Please indicate the Residence of the Applicant as **Seoul, Republic of Korea.**

Applicant additionally requests that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: March 31, 2004

Respectfully submitted,

By   
Rebecca Goldman Rudich

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30827

PATENT TRADEMARK OFFICE

**COPY**

## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/733,237	12/12/2003	2822	770	8733.713.10-US	3	11	1

MCKENNA LONG & ALDRIDGE LLP  
 Song K. Jung  
 1900 K Street, N.W.  
 Washington, DC 20006



CONFIRMATION NO. 9469

## FILING RECEIPT



\*OC000000012160970\*

Date Mailed: 03/24/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Han-Wook Hwang, Residence Not Provided;

RGR

## Domestic Priority data as claimed by applicant

This application is a DIV of 10/279,934 10/25/2002 PAT 6,713,825

## Foreign Applications

REPUBLIC OF KOREA 2001-87446 12/28/2001

If Required, Foreign Filing License Granted: 03/18/2004

Projected Publication Date: 07/01/2004

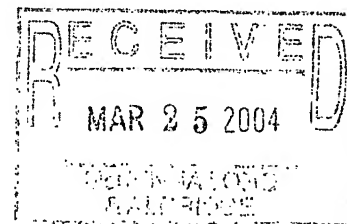
Non-Publication Request: No

Early Publication Request: No

## Title

Poly-crystalline thin film transistor and fabrication method thereof

## Preliminary Class



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**Title 37, Code of Federal Regulations, 5.11 & 5.15**

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